



00862.022434.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Shinichi SHIMA)
Application No.: 09/986,958)
Filed: November 13, 2001)
For: EXPOSURE APPARATUS, METHOD OF)
MANUFACTURING SEMICONDUCTOR)
DEVICES, SEMICONDUCTOR MANUFAC-)
TURING PLANT, METHOD OF MAINTAIN-)
ING EXPOSURE APPARATUS, AND POSITION)
DETECTOR)

Examiner: H. Nguyen
Group Art Unit: 2851
April 24, 2003

#6/a
4/30/03
am
(entered
in part)

The Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

Sir:

In response to the Official Action dated January 24, 2003, please amend the above-identified application as follows:

INTRODUCTORY COMMENTS

This Amendment has been prepared in accordance with the Revised Format established by the U.S. Patent and Trademark Office, as permitted in the Pre-OG Notice dated February 4, 2003, and entitled "Amendments in a Revised Format Now Permitted."